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About the Author



Max J. Riedl was born in Kempten, Germany, where he was educated at the Mathematisch Mechanisches Institut. He also graduated from the Akademie für angewandte Technik in Munich, where he studied precision mechanics and optics. He has worked in the field of mathematical and optical instruments for many years and holds numerous patents for mechanical, optical, and electro-optical devices. He held technical as

well as business leadership positions during the 45 years he lived in the United States. He has published and presented many papers on fundamental lens design as well as on replicating optical elements and diamond turning diffractive optical components for applications in the infrared spectrum. He regularly teaches short courses on these subjects. He is the author of the well-received tutorial text *Optical Design Fundamentals for Infrared Systems* (SPIE Press, Vol. TT48), which is now in its second edition. He has also translated that textbook into German. He is a Fellow of SPIE. Presently, he resides in Bavaria, Germany.